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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Sumio IIJIMA et al. : Confirmation No. 4026

Serial No. 10/521,575 : Mail Stop: PCT BRANCH

Filed July 20, 2005 : Attorney Docket No. 2005_0065A

STRUCTURES SELECTING METHOD FOR
CARBON NANOTUBES BY LIGHT
IRRADIATION

REQUEST FOR CORRECTED FILING RECEIPT

Commissioner for Patents
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Sir:

A corrected filing receipt is requested in the above-referenced case. A copy of the original filing receipt is enclosed, with the changes noted thereon.

Expedited issuance of the corrected filing receipt is respectfully requested.

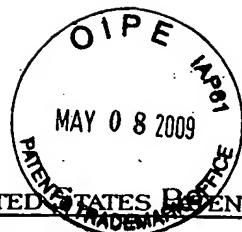
Respectfully submitted,

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By


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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE RECD	ATTY.DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/521,575	07/20/2005	3726	1030	2005_0065A	3	6	1

CONFIRMATION NO. 4026

FILING RECEIPT



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513
 WENDEROTH, LIND & PONACK, L.L.P.
 2033 K STREET N. W.
 SUITE 800
 WASHINGTON, DC 20006-1021

Date Mailed: 09/08/2005

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Applicant(s)

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Power of Attorney: The patent practitioners associated with Customer Number 513.

Domestic Priority data as claimed by applicant

This application is a 371 of PCT/JP03/04182 04/01/2003

Foreign Applications

JAPAN 2003-000718 01/06/2003

Projected Publication Date: To Be Determined - pending completion of Security Review

Non-Publication Request: No

Early Publication Request: No

Title

STRUCTURES SELECTING METHOD FOR CARBON NANOTUBES BY LIGHT IRRADIATION
 Method of selecting structure of carbon nanotube through photoirradiation.

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Preliminary Class

029

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